

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application No.:

09/744,877

Confirmation No.:

8711

Filing Date:

January 29, 2001

Inventors:

Halimaoui et al.

Title:

PROCESS FOR FORMING

AN OXIDE LAYER OF

**NON-UNIFORM** THICKNESS ON THE

SURFACE OF A SILICON

**SUBSTRATE** 

Examiner:

Novacek, Christy L.

Art Unit:

2822

Atty. Dkt. No:

5310-03000

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8

DATE OF DEPOSIT:

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail on the date indicated above and is addressed to:

Commissioner for Patents P.O. Box 1450

## AMENDMENT; REMARKS TO ADVISORY ACTION MAILED DECEMBER 29, 2003

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Advisory Action mailed December 29, 2003 please amend the abovespecified application as follows:

Amendments to the claims are reflected in the listing of claims that begin on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.